



Attorney's Docket No.: 042390P10057D

Patent

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re Application of:)

Wong, Alan)

U.S. Serial No: 10/662,021)

Examiner: Whitmore, Stacy A.

Filed: September 11, 2003)

Art Unit: 2812

For: METHOD OF DETERMINING)
POST-ETCH OFFSET IN)
EXPOSED-TO-EMBEDDED OVERLAY)
(as amended))

Commissioner for Patents
P. O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT AND RESPONSE

Dear Sir:

This is in response to the Office Action mailed March 5, 2004. Applicant respectfully requests the Examiner to enter the following amendments and consider the following remarks.

FIRST CLASS CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail with sufficient postage in an envelope addressed to the Assistant Commissioner of Patents, Washington, D.C. 20231

on March 15, 2004

Date of Deposit

Teresa Mattox

Name of Person Mailing Correspondence

Signature

Date